

# Routes for Rapid Synthesis of CuIn<sub>x</sub>Ga<sub>1-x</sub>Se Absorbers

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# Why Should We Build Solar Cells?

# Why do you rob banks, Willy?

# "Cause that's where the money is!"

# Willy Sutton Bank Robber





# Because That Is Where the Energy Is!





# **Classification of Solar Cells**





### Most Promising Thin Film Absorber Material

- Direct band gap (Eg  $\sim 1.2 \text{ eV}$ )
- High optical absorption coefficient:  $\sim 2 \ \mu m$
- High radiation resistance
- High reliability
- Lower cost per Watt installed
- High conversion efficiency: cell: 20% and module: 13%
- Efficient in low-angle & low-light conditions
- Flexible substrates possible (BIPV, cheaper substrates?)
- Positive response under concentration





**Chalcopyrite structure** 

# Key Issue: Cost Reduction - \$/W<sub>p</sub>

Materials Costs (~50%) Material efficient deposition – Lower substrate cost (e.g. BIPV) » Lower temperature Processing Costs Capitalization largest cost » Process intensification » Increase process yield (e.g., process control) » Increase throughput (e.g., scale-up, reduce absorber thickness, high rate deposition/rapid reaction pathway/lower temperature) Increase Cell Efficiency – For advanced technologies: Module level <</p> Champion cell ~ Predicted

# Comparison of Simulated and Reported *Photo- J-V* and Quantum Efficiency





# NREL 3-stage Process: Champion Cell









**DICTRA** Atomic Mobilities Chemical Potentials



# Approach to Developing Phase Diagrams





### Comparison of Calculated Cu-Se Phase Diagram with Experimental Data

<b>Phase</b>	Model		
Liquid	Ionic two sub-lattice model		
	(Cu+1,Cu+2)p(Se-2,Va,Se)q		
$\alpha$ -Cu <sub>2-x</sub> Se	Sub-lattice model (3 sub-lattices)		
	$(Cu, Va)_1(Se, Va)_1(Cu)_1$		
β-Cu <sub>2-x</sub> Se	Sub-lattice model (3 sub-lattices)		
	$(Cu, Va)_1(Se, Va)_1(Cu)_1$		
Fcc (Cu)	<b>Regular solution model</b>		





### Se<sub>2</sub> Partial Pressure







![](_page_12_Picture_0.jpeg)

# **Phase Diagram of Cu-In-Se**

#### Isothermal section at 500 °C (18 phases)

![](_page_12_Figure_3.jpeg)

Region	Equilibrium phases		
1	$\alpha$ -CISe <sub>2</sub> + $\alpha$ -Cu + $\beta$ -Cu <sub>2</sub> Se		
2	$\alpha$ -CISe <sub>2</sub> + $\alpha$ -Cu + Cu <sub>7</sub> In <sub>3</sub>		
3	$\alpha$ -CISe <sub>2</sub> + Cu2In + Cu <sub>7</sub> In <sub>3</sub>		
4	$\alpha$ -CISe <sub>2</sub> + Cu2In + In <sub>4</sub> Se <sub>3</sub>		
5	$\alpha$ -CISe <sub>2</sub> + InSe + In <sub>4</sub> Se <sub>3</sub>		
6	$\alpha$ -CISe <sub>2</sub> + InSe + $\delta$ -CuInSe <sub>2</sub>		
7	$\alpha$ -CISe <sub>2</sub> + $\beta$ -CuIn <sub>3</sub> Se <sub>5</sub> + $\delta$ -CuInSe <sub>2</sub>		
8	$\alpha$ -CISe <sub>2</sub> + $\beta$ -CuIn <sub>3</sub> Se <sub>5</sub> + Liquid		
9	$\alpha$ -CISe <sub>2</sub> + $\beta$ -Cu <sub>2</sub> Se + Liquid		

![](_page_13_Picture_0.jpeg)

### **Chemical Potential Diagram**

![](_page_13_Figure_2.jpeg)

![](_page_13_Picture_3.jpeg)

Reg.	Equilibrium phases	
1	$\alpha$ -ClSe <sub>2</sub> + $\alpha$ -Cu + $\beta$ -Cu <sub>2</sub> Se	
2	$\alpha$ -CISe <sub>2</sub> + $\alpha$ -Cu + Cu <sub>7</sub> In <sub>3</sub>	
3	$\alpha$ -CISe <sub>2</sub> + Cu <sub>2</sub> In + Cu <sub>7</sub> In <sub>3</sub>	
4	$\alpha$ -CISe <sub>2</sub> + Cu <sub>2</sub> In + In <sub>4</sub> Se <sub>3</sub>	
5	$\alpha$ -CISe <sub>2</sub> + InSe + In <sub>4</sub> Se <sub>3</sub>	
6	$\alpha$ -CISe <sub>2</sub> + InSe + $\delta$ -CuInSe <sub>2</sub>	
7	$\alpha$ -CISe <sub>2</sub> + β-CuIn <sub>3</sub> Se <sub>5</sub> + δ-CuInSe <sub>2</sub>	
8	$\alpha$ -CISe <sub>2</sub> + $\beta$ -CuIn <sub>3</sub> Se <sub>5</sub> + Liquid	
9	$\alpha$ -CISe <sub>2</sub> + $\beta$ -Cu <sub>2</sub> Se + Liquid	

![](_page_14_Figure_0.jpeg)

![](_page_14_Picture_1.jpeg)

![](_page_14_Figure_2.jpeg)

**DICTRA** Atomic Mobilities Chemical Potentials

![](_page_15_Picture_0.jpeg)

# **UF PMEE Reactor System**

![](_page_15_Figure_2.jpeg)

- ➔ Ultra high vacuum system
- → Operating pressure : ~  $10^{-8}$  Torr

- Rotating platen with 9 substrates (2×2 inches)
- Sequential deposition

![](_page_16_Picture_0.jpeg)

![](_page_16_Picture_1.jpeg)

![](_page_16_Figure_2.jpeg)

#### →High Temperature Materials Laboratory (ORNL)

#### **Graphite Dome**

![](_page_16_Figure_5.jpeg)

![](_page_17_Picture_0.jpeg)

# **Pathway Studies**

# Binary Metal-Se Precursors

- -Co-deposited Se-M/glass
- Bilayer Se/M/glass

### Ternary Precursors

- -Metal Selenization
- -Co-deposited
- -<u>Bilayer Compounds: e.g.</u> <u>CuSe/GaSe/glass</u>
- Quaternary Precursors
- Nanopowders

![](_page_18_Picture_0.jpeg)

# **Ga+Se Precursor Annealing**

![](_page_18_Figure_2.jpeg)

![](_page_19_Picture_0.jpeg)

# Se/Ga Precursor Annealing

![](_page_19_Figure_2.jpeg)

![](_page_20_Picture_0.jpeg)

### **Ga-Se Phase Diagram**

![](_page_20_Figure_2.jpeg)

![](_page_21_Picture_0.jpeg)

# Pathways for Binary Precursor Structures

![](_page_21_Figure_2.jpeg)

![](_page_22_Figure_0.jpeg)

# **Temperature Ramp Anneal**

![](_page_22_Figure_2.jpeg)

![](_page_23_Picture_0.jpeg)

# **Isothermal annealing**

![](_page_23_Figure_2.jpeg)

![](_page_24_Picture_0.jpeg)

### **TEM-EDS Analysis**

#### Glass/GaSe/CuSe Precursor

![](_page_24_Figure_3.jpeg)

![](_page_25_Picture_0.jpeg)

### **TEM-EDS Analysis**

#### Glass/GaSe/CGS/CuSe annealed for 30 min, at 300 °C

![](_page_25_Figure_3.jpeg)

![](_page_26_Picture_0.jpeg)

# **Isothermal annealing**

![](_page_26_Figure_2.jpeg)

![](_page_27_Picture_0.jpeg)

# **Solid-state Growth Models**

### Parabolic growth model

![](_page_27_Picture_3.jpeg)

Before reaction

![](_page_27_Figure_5.jpeg)

Nucleation at A-B interface

![](_page_27_Figure_7.jpeg)

Diffusion thru product & reaction (ex. D<sub>BC</sub> > D<sub>AC</sub>)

![](_page_27_Figure_9.jpeg)

### Avrami growth model

![](_page_27_Figure_11.jpeg)

# **Kinetic Analysis**

![](_page_28_Figure_1.jpeg)

![](_page_28_Figure_2.jpeg)

#### Avrami model

![](_page_28_Figure_4.jpeg)

 $\alpha^2 \sim \mathbf{k} \cdot \mathbf{t}$ 

 $\ln[-\ln(1-\alpha)] = n \ln(t+t^*) + n \ln k$ 

➔ Analysis suggests one-dimensional diffusion controlled reaction

![](_page_29_Picture_0.jpeg)

# **CuInSe<sub>2</sub> Formation Pathway**

![](_page_29_Figure_2.jpeg)

![](_page_29_Figure_3.jpeg)

### $CuSe + InSe \rightarrow CuInSe_2$

 $(E_a=66 \text{ kJ/mol})$ 

![](_page_30_Picture_0.jpeg)

# **CulinSe<sub>2</sub> Formation Pathway**

![](_page_30_Figure_2.jpeg)

![](_page_30_Figure_3.jpeg)

CuSe +  $In_2Se_3$   $\rightarrow$  CuInSe\_2 + Se (E<sub>a</sub>=162 kJ/mol)

![](_page_31_Picture_0.jpeg)

# **CulinSe<sub>2</sub> Formation Pathway**

![](_page_31_Figure_2.jpeg)

![](_page_31_Figure_3.jpeg)

(E<sub>a</sub>=100 ~ 124 kJ/mol)

![](_page_32_Picture_0.jpeg)

# **CulinSe<sub>2</sub> Formation Pathway**

![](_page_32_Figure_2.jpeg)

![](_page_32_Figure_3.jpeg)

#### $Cu + In + Se \rightarrow CuInSe_2$

Very fast !! No intermediate phase No diffusion barrier !!

![](_page_33_Picture_0.jpeg)

**Reaction rate** 

#### Avrami model

![](_page_33_Figure_3.jpeg)

	Precursors	Activation energy (kJ/mol)	
		Avrami	Parabolic
1	InSe/CuSe	66	65
2	CuSe/In <sub>2</sub> Se <sub>3</sub>	N/A	162 (±5)
3	Cu-In + Se(vapor)	124 (±19)	100 (±14)
4	GaSe/CuSe	118 (±22)	107 (±15)
5	Cu-Ga + Se(vapor)	108	N/A
6	Cu/In/Ga + Se(vapor)	144	N/A

![](_page_34_Picture_0.jpeg)

![](_page_34_Picture_1.jpeg)

U. Farva & C. Park

![](_page_35_Picture_0.jpeg)

![](_page_35_Figure_1.jpeg)

![](_page_35_Figure_2.jpeg)

![](_page_35_Picture_3.jpeg)

![](_page_36_Picture_0.jpeg)

# **Cu-Se Phase Diagram**

![](_page_36_Figure_2.jpeg)

# How Can We Synthesize High Quality CIGS Rapidly?

Sutton's law states that in attempting to diagnose a problem, one should first do the experiment that can confirm the most likely diagnosis. "When you hear hoof beats in Texas, think horses, not zebras."

![](_page_37_Picture_2.jpeg)

![](_page_38_Figure_0.jpeg)

# Conclusions

Pathways are dependent on precursor structure

- In phase particularly important
- Most paths are diffusion limited
- High-rate processes are possible
  - Film quality needs assessed
  - Liquid phase assisted growth
- Point defect chemistry helpful (low disordering energy)
  - Enhance diffusivity, defect compensation, type-inversion, impurity passivation